

Application/Control No.	Applicant(s)/Patent under Reexamination
09/558,923	KEMBEL ET AL.
Examiner	Art Unit
Chau Nguven	2176

SEARCHED					
Class	Subclass	Date	Examiner		
709	203	5/28/2003	CN		
709	200	5/28/2003	CN		
709	206	5/28/2003	CN		
709	245	5/28/2003	CN		
709	245	5/28/2003	CN		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East Reports	05/27/2003	CN		
	5/28/2003	CN		
Updated Search on East Reports (Text Search)	10/14/2004	CN		
	10/15/2004	CN		
Updated Search on East Reports (Text Search)	6/24/2005	CN		
	06/28/2005	CN		
	6/29/2005	CN		